Serial No. 09/943,383

Docket No.: 005920 USA/MTCG/PCTRL/JW

PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,383

Group Art Unit: 2862

Filed: August 31, 2001

: Examiner: William David Coleman

For:

IN SITU SENSOR BASED CONTROL OF SEMICONDUCTOR PROCESSING

PROCEDURE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. IT is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Applicants' representative certifies that the enclosed document was cited in a communication from the World Intellectual Property Office in a counterpart PCT application not more than three months before the filing date of this Information Disclosure Statement. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Serial No. 10/685,210

the filing date of this Information Disclosure Statement.

No fee is believed to be required; however, the Commissioner is authorized to charge any deficiency in any fees pursuant to 37 CFR § 1.17 associated with this communication and to credit any excess payment to Deposit Account No. 08-0219.

Respectfully submitted,

WILMER CUTLER PICKERING HALE AND DORR LLP

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CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 007967 USA/PPC/ECP/RKK		SERIAL NO. 10/685,210		
				APPLICANT Lawrence C. LEI et al.				
				FILING DATE October 14, 2003		GROUP 2862		
		U.	S. PATENT D	OCUMENTS	•			
EXAMINER'S INITIALS PATENT NO.		DATE		NAME	CLASS	SUBCLASS		ING ATE
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EXAMINER'S	(e. 7)	DOCUMENTS	,			Translation		
INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Yes	No
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

January 28, 2005. Written Opinion from PCT Application No. PCT/US03/39551.

EXAMINER DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.